University Of California, Berkeley  
Department of Mechanical Engineering

ME 238: Advanced MEMS and NEMS Laboratory (3 units)  
Graduate Course 

Syllabus 

CATALOG DESCRIPTION  

This hands-on laboratory course focuses on the mechanical engineering principles that underlie the design, fabrication, and operation of micro/nanoscale mechanical systems, including devices made by nanowire/nanotube syntheses; photolithography/soft lithography; and molding processes. Each lab will have different focuses for basic understanding of MEMS/NEMS systems from prototype constructions to experimental tests using mechanical, electrical or optical techniques. Students will work in teams to design, analyze, simulate, fabricate and test their own micro/nano devices in the final project. Graduate students are required to utilize analytical models and/or numerical simulations (in solid, fluid or other fields) in each lab for in-depth analyses of the MEMS/NEMS systems.

COURSE PREREQUISITES  

EECS 100, ME 106, (ME119 or ME118 are highly recommended but not mandatory)

TEXTBOOK(S) AND/OR OTHER REQUIRED MATERIAL  

None

COURSE OBJECTIVES  

This class provides students with hands-on experiences in MEMS/NEMS device design, fabrication and operation from concept to prototype manufacturing and experimental tests in areas such as nanowires/nanotube synthesis; photolithography/soft lithography; and molding processes. This course provides laboratory experiences for ME students on how to combine various technologies in nano/micro structures syntheses, fundamental principles in mechanical engineering (fluid dynamics, heat transfer, solid mechanics) and computational analyses tools to facilitate engineering design analysis and practice. This course will provide a foundation for MEMS/NEMS design, fabrication and operation of devices and systems encountered in a variety of applications.

DESIGNED COURSE OUTCOMES  

Students will gain hands-on experiences of the design, synthesis, fabrication and operation of a wide variety of MEMS/NEMS devices and systems, including multidisciplinary nature of the operational principles and various fabrications and testing methodologies. Students will gain an understanding of how to design, fabricate and test common MEMS/NEMS devices and systems.

TOPICS COVERED  

See attached tentative schedule
CLASS/LABORATORY SCHEDULE

Two hours of lecture and 3 hours of laboratory per week

CONTRIBUTION OF THE COURSE TO MEETING THE PROFESSIONAL COMPONENT

This course is an elective course in the Mechanical Engineering for hands-on experiences of MEMS/NEMS systems

ASSESSMENT OF STUDENT PROGRESS TOWARD COURSE OBJECTIVES

The course grade will be based on laboratory reports (40%), quiz (20%), and a final project (40%).

REMARKS

This is a room-share course for both ME 138 and ME 238 to be taught concurrently with a common lecture, but labs and project assignments for graduate students in ME 238 will have extra depth. Compared to the labs and project assigned to undergraduates, graduate students taking ME 238 will be given assignments that require modeling of complex systems, and the use of more sophisticated computational tools.

PERSON(S) WHO PREPARED THIS DESCRIPTION

Professor Liwei Lin, 10/17/2012

ABBREVIATED TRANSCRIPT TITLE (19 SPACES MAXIMUM): ADV MEMS/NEMS LAB
TIE CODE: LABS
GRADING: Letter
SEMESTER OFFERED: Fall and Spring
COURSES THAT WILL RESTRICT CREDIT: ME 138
INSTRUCTORS: Professor Lin
DURATION OF COURSE: 14 weeks
EST. TOTAL NUMBER OF REQUIRED HRS OF STUDENT WORK PER WEEK: 9
IS COURSE REPEATABLE FOR CREDIT? No
CROSSLIST: None
ROOMSHARE: w/ ME 138